

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/516,688	MOTOMIYA ET AL.	
Examiner	Art Unit	
Regina M. DeBerry	1647	

	SEARCHED				
Class	Subclass	Date	Examiner		
None			RMD		
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TAI	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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	DATE	EXMR
WEST (See history printout)	2/1/2006	RMD
STN (See history printout)	2/1/2006	RMD